

**NON-LINEAR ANALYSIS OF COMPOSITE STRUCTURES WITH INTEGRATED PIEZOELECTRIC
SENSORS AND ACTUATORS**

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Abstract

This paper deals with the geometrically non-linear analysis of thin plate/shell laminated structures with embedded integrated piezoelectric actuators or sensors layers and/or patches. The model is based on the Kirchhoff classical laminated theory and can be applied to plate and shell adaptive structures with arbitrary shape, general mechanical and electrical loadings. The finite element model is a nonconforming single layer triangular plate/shell element with 18 degrees of freedom for the generalized displacements and one electrical potential degree of freedom for each piezoelectric layer or patch. An updated Lagrangian formulation associated to Newton-Raphson technique is used to solve incrementally and iteratively the equilibrium equations. The model is applied in the solution of four illustrative cases, and the results are compared and discussed with alternative solutions when available.

Introduction

In the recent years the study of smart structures has attracted significant researchers, due to their potential benefits in a wide range of applications, such as shape control, vibration suppression, noise attenuation and damage detection. The use of smart materials, such as piezoelectric materials, in the form of layers or patches embedded and/or surface bonded on laminated composite structures, can provide structures that combine the superior mechanical properties of composite materials and the capability to sense and adapt their static and dynamic response. The piezoelectric materials have the property to generate electrical charge under mechanical load or deformation, and the reverse, applying an electrical field to the material results in mechanical strains or stresses.

Many researchers considering mainly linear analysis have carried out the modelling of composite structures containing piezolaminated sensors and actuators using the finite element formulation. A pioneering work is due to Allik and Hughes [1], which analysed the interactions between electricity and elasticity by developing a tetrahedral finite element. Recent surveys can be found in Benjeddou [2], Senthil *et al.* [3] and Franco Correia *et al.* [4]. Recently Yi *et al.* [5] has developed a 3D finite element model to carry out the non-linear dynamic response of laminated adaptive structures using an updated Lagrangian formulation. A twenty-node solid element including electrical degrees of freedom is developed to analyse structures with piezoelectric sensors and actuators, and multipoint constraints for electrical degrees of freedom are used to simulate electrodes. The numerical results show that the deflection amplitude, vibration frequency and output voltage are significantly influenced by the large deformation of structures. A fully non-linear theory and corresponding model with integrated piezoelectric actuators and sensors accounting for geometric nonlinearities by using local stresses and strains measures and an exact co-ordinate transformation has been developed by Pai *et al.* [6] and applied to active control of plates. The model includes shear deformation of anisotropic laminated plates and assumes a higher order displacement field for in-plane displacements. Icardi *et al.* [7] also presents a mathematical model with detailed investigation of 3-D stress field of multilayered adaptive plates based on von Karman strain-displacement relations. Numerical results are presented for simply supported cross-ply plates with top and bottom actuators in cylindrical bending under distributed transverse loading.

In this paper we present a finite element model, based on classical plate theory, for static non-linear analysis of plate/shell structures with piezoelectric sensors and actuators. A simple and efficient three-node triangular piezolaminated plate/shell element with 18 generalised displacement degrees of freedom is used. The formulation introduces one electric potential degree of freedom for each piezoelectric layer of the finite element model. To show the applicability of the proposed model illustrative numerical examples are presented and compared with alternative solutions when available.

1 Displacement and Strain Fields

The classical Kirchhoff theory is considered. The displacement components (Figure 1) of a generic point in the laminated finite element local axes (x,y,z) are assumed to be of the form:

$$\begin{aligned} u(x, y, z) &= u_0(x, y) - z \theta_y \\ v(x, y, z) &= v_0(x, y) + z \theta_x \\ w(x, y, z) &= w_0(x, y) \end{aligned} \tag{1}$$

where (u_0, v_0, w_0) are the displacements of the point on the reference plane of the laminate, and

$\theta_x = -\frac{\partial w}{\partial y}$ and $\theta_y = \frac{\partial w}{\partial x}$ are the rotations about the x and y axes respectively.

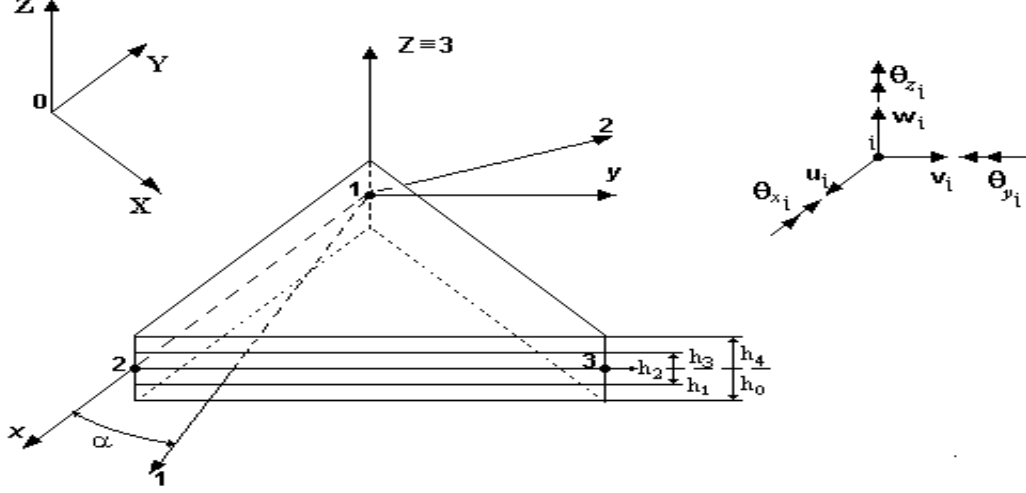


Figure 1. Three node triangular finite element with material (1,2,3) and geometric (x,y,z) coordinate

The present theory considers large displacements with small strains. The Green's strains components associated with the displacement in equation (1) are given by:

$$\begin{aligned}\epsilon_{xx} &= \frac{\partial u_0}{\partial x} - z \frac{\partial \theta_y}{\partial x} + \frac{1}{2} \left[\left(\frac{\partial u_0}{\partial x} \right)^2 + \left(\frac{\partial v_0}{\partial x} \right)^2 + \left(\frac{\partial w_0}{\partial x} \right)^2 \right] \\ \epsilon_{yy} &= \frac{\partial v_0}{\partial y} - z \frac{\partial \theta_x}{\partial y} + \frac{1}{2} \left[\left(\frac{\partial v_0}{\partial y} \right)^2 + \left(\frac{\partial w_0}{\partial y} \right)^2 + \left(\frac{\partial u_0}{\partial y} \right)^2 \right] \\ \epsilon_{xy} &= \left(\frac{\partial u_0}{\partial y} + \frac{\partial v_0}{\partial x} \right) + z \left(\frac{\partial \theta_y}{\partial y} + \frac{\partial \theta_x}{\partial x} \right) + \left(\frac{\partial u_0}{\partial x} \frac{\partial u_0}{\partial y} + \frac{\partial v_0}{\partial x} \frac{\partial v_0}{\partial y} + \frac{\partial w_0}{\partial x} \frac{\partial w_0}{\partial y} \right)\end{aligned}\quad (2)$$

3. Piezoelectric Laminates. Constitutive Equations.

In a piezoelectric material, the interaction between the mechanical and electrical fields is defined by Maxwell equations [8],

$$\Phi = \frac{1}{2} C_{ijkl} \epsilon_{ij} \epsilon_{kl} - e_{ijk} \epsilon_{ij} E_k - \frac{1}{2} p_{kl} E_k E_l \quad (3)$$

such that

$$\sigma_{ij} = \frac{\partial \Phi}{\partial \epsilon_{ij}} \quad ; \quad D_i = -\frac{\partial \Phi}{\partial E_i} \quad (4)$$

where $\mathbf{E}$ is the electric field vector, $\mathbf{D}$ the electric displacement vector, $\mathbf{C}$ the tensor of elasticity moduli, $\mathbf{e}$ the strain tensor, $\mathbf{s}$ the stress tensor, $\mathbf{e}$ the tensor of piezoelectric moduli, and $\mathbf{p}$ the tensor of dielectric constants, in material axes 1,2,3.

Substituting equations (3) into (4), the constitutive equations of a deformable piezoelectric medium are obtained. The linear piezoelectric constitutive equations coupling the elastic field and the electric field can be written as [9]

$$\begin{aligned}\bar{\mathbf{s}} &= \bar{\mathbf{Q}} \bar{\mathbf{e}} - \bar{\mathbf{e}} \bar{\mathbf{E}} \\ \bar{\mathbf{D}} &= \bar{\mathbf{e}}^T \bar{\mathbf{e}} + \bar{\mathbf{p}} \bar{\mathbf{E}}\end{aligned}\quad (5)$$

where $\bar{\boldsymbol{\sigma}} = [\sigma_{xx} \ \sigma_{yy} \ \sigma_{xy}]^T$ is the elastic stress vector and $\bar{\boldsymbol{\varepsilon}} = [\varepsilon_{xx} \ \varepsilon_{yy} \ \gamma_{xy}]^T$ the elastic strain vector, $\bar{\mathbf{Q}}$ the elastic constitutive matrix, $\bar{\mathbf{e}}$ the piezoelectric stress coefficients matrix, $\bar{\mathbf{E}}$ the electric field vector, $\bar{\mathbf{D}}$ the electric displacement vector and $\bar{\mathbf{p}}$ the dielectric matrix in the element local system (x,y,z) of the laminate.

The transformation of vectors and matrices from the orthogonal material axes system (1,2,3) to the local orthogonal system (x,y,z) of the laminate, in a state of plane stress, with transversal strains neglected, yields:

$$\bar{\mathbf{Q}} = \begin{bmatrix} \bar{Q}_{11} & \bar{Q}_{12} & \bar{Q}_{16} \\ \bar{Q}_{21} & \bar{Q}_{22} & \bar{Q}_{26} \\ \bar{Q}_{61} & \bar{Q}_{62} & \bar{Q}_{66} \end{bmatrix} \quad (6)$$

$$\bar{\mathbf{e}} = \begin{bmatrix} 0 & 0 & \bar{e}_{31} \\ 0 & 0 & \bar{e}_{32} \\ 0 & 0 & \bar{e}_{36} \end{bmatrix} \quad (7)$$

$$\bar{\mathbf{p}} = \begin{bmatrix} \bar{p}_{11} & \bar{p}_{12} & 0 \\ \bar{p}_{21} & \bar{p}_{22} & 0 \\ 0 & 0 & \bar{p}_{33} \end{bmatrix} \quad (8)$$

where $\bar{Q}_{ij}$ are functions of ply angle α for the K^{th} layer, and are explicitly given in Reddy [9], and the piezoelectric and dielectric coefficients in the system (x,y,z) axes are related with the corresponding coefficients in the system (1,2,3) axes for the piezoelectric layers through [9]:

$$\begin{aligned}\bar{e}_{31} &= e_{31} \cos^2 \alpha + e_{32} \sin^2 \alpha & ; & \quad \bar{p}_{11} = p_{11} \cos^2 \alpha + p_{22} \sin^2 \alpha \\ \bar{e}_{32} &= e_{31} \sin^2 \alpha + e_{32} \cos^2 \alpha & ; & \quad \bar{p}_{22} = p_{11} \sin^2 \alpha + p_{22} \cos^2 \alpha \\ \bar{e}_{36} &= (e_{31} - e_{32}) \sin \alpha \cos \alpha & ; & \quad \bar{p}_{12} = (p_{11} - p_{22}) \sin \alpha \cos \alpha \\ & & & \quad \bar{p}_{33} = p_{33}\end{aligned}\quad (9)$$

The electric field vector is the negative gradient of the electric potential ϕ , which is assumed to vary linearly in the thickness t_k direction, i.e.

$$\bar{\mathbf{E}} = -\nabla \phi \quad (10)$$

$$\bar{\mathbf{E}} = \{0 \quad 0 \quad E_z\}^T \quad (11)$$

where

$$E_z = -\phi / t_k \quad (12)$$

Observing that [9]:

$$\bar{\mathbf{e}} = \bar{\mathbf{Q}} \bar{\mathbf{d}} \quad (13)$$

with

$$\bar{\mathbf{d}} = \begin{bmatrix} 0 & 0 & \bar{d}_{31} \\ 0 & 0 & \bar{d}_{32} \\ 0 & 0 & \bar{d}_{36} \end{bmatrix} \quad (14)$$

where $\bar{\mathbf{d}}$ is the piezoelectric strain coefficient matrix in the local system (x,y,z) of the laminate, the equations (5) can also be written in the form:

$$\begin{aligned} \bar{\mathbf{s}} &= \bar{\mathbf{Q}} (\bar{\mathbf{e}} - \bar{\mathbf{d}} \bar{\mathbf{E}}) \\ \bar{\mathbf{D}} &= (\bar{\mathbf{Q}} \bar{\mathbf{d}})^T \bar{\mathbf{e}} + \bar{\mathbf{p}} \bar{\mathbf{E}} \end{aligned} \quad (15)$$

We can define the strain vector for electroelasticity in the form:

$$\hat{\mathbf{e}} = \begin{Bmatrix} \bar{\mathbf{e}}^L + \bar{\mathbf{e}}^{NL} \\ -\bar{\mathbf{E}} \end{Bmatrix} \quad (16)$$

where the mechanical strains are given by the sum of its linear and non-linear parts.

The linear part can be written in the form:

$$\bar{\mathbf{e}}^L = \bar{\mathbf{e}}_m^L + z \bar{\mathbf{e}}_b^L \quad (17)$$

The constitutive equations (5) can be written in the synthetic form:

$$\hat{\mathbf{s}} = \begin{Bmatrix} \bar{\mathbf{s}} \\ \bar{\mathbf{D}} \end{Bmatrix} = \begin{bmatrix} \bar{\mathbf{Q}} & \bar{\mathbf{e}} \\ \bar{\mathbf{e}}^T & \bar{\mathbf{p}} \end{bmatrix} \begin{Bmatrix} \bar{\mathbf{e}}^L + \bar{\mathbf{e}}^{NL} \\ -\bar{\mathbf{E}} \end{Bmatrix} = \hat{\mathbf{C}} \hat{\mathbf{e}} \quad (18)$$

Integrating the stress vector $\bar{\mathbf{s}}$ through the laminate thickness, and substituting the vector $\bar{\mathbf{s}}$ by the first of equations (15), where the stresses are obtained as in linear analysis [10], one obtains the resultant forces and moments acting on the laminate:

$$\tilde{\mathbf{S}} = \begin{Bmatrix} \mathbf{N} \\ \mathbf{M} \end{Bmatrix} = \begin{bmatrix} \mathbf{A} & \mathbf{B} \\ \mathbf{B} & \mathbf{D} \end{bmatrix} \begin{Bmatrix} \bar{\mathbf{e}}_m^L \\ \bar{\mathbf{e}}_b^L \end{Bmatrix} - \begin{bmatrix} \mathbf{A}' & 0 \\ 0 & \mathbf{B}' \end{bmatrix} \begin{Bmatrix} \bar{\mathbf{E}} \\ \bar{\mathbf{E}} \end{Bmatrix} \quad (19)$$

where the elements of the mechanical stiffness, for extensional, bending-extensional coupling and bending are given by:

$$\begin{aligned} A_{ij} &= \sum_{k=1}^N \bar{Q}_{ij} (h_k - h_{k-1}) \\ B_{ij} &= \sum_{k=1}^N \bar{Q}_{ij} (h_k^2 - h_{k-1}^2) / 2 \quad (i, j = 1, 2, 6) \\ D_{ij} &= \sum_{k=1}^N \bar{Q}_{ij} (h_k^3 - h_{k-1}^3) / 3 \end{aligned} \quad (20)$$

The elements of the piezoelectric stiffness are:

$$\begin{aligned} A'_{ij} &= \sum_{k=1}^{N^p} \bar{Q}_{im} \bar{d}_{mj} (h_k - h_{k-1}) \\ B'_{ij} &= \sum_{k=1}^{N^p} \bar{Q}_{im} \bar{d}_{mj} (h_k^2 - h_{k-1}^2) / 2 \end{aligned} \quad (i, m, j = 1, 2, 6) \quad (21)$$

where h is the laminate thickness and h_k, h_{k-1} are the distances from the reference surface to the upper and lower surfaces of the K th layer, N is the number of layers, and N^p is the number of layers or patches with piezoelectric material.

Integrating the vector $\bar{\mathbf{D}}$ through the thickness of piezoelectric patch or layer, and substituting the vector $\bar{\mathbf{D}}$ by the second of equations (15), yields:

$$\tilde{\mathbf{D}} = \begin{bmatrix} \mathbf{A}' & \mathbf{B}' \end{bmatrix} \begin{Bmatrix} \bar{\mathbf{e}}_m^L \\ \bar{\mathbf{e}}_b^L \end{Bmatrix} - [\mathbf{A}''] \{\mathbf{E}\} \quad (22)$$

where

$$A''_{ij} = \sum_{k=1}^{N^p} \bar{p}_{ij} (h_k - h_{k-1}) \quad (i, j = 1, 2, 3) \quad (23)$$

4. Finite element formulation.

4.1 Updated Lagrangian formulation.

The virtual work principle is used in conjugation with an updated Lagrangian formulation to obtain the governing equations. A reference configuration is associated with time t , and the actualized

configuration is associated with the current time $t + \Delta t$. The formulation of the element follows the development presented by Bathe [10]. The linearized equilibrium equations for a laminate finite element are:

$$\begin{aligned} & \sum_{K=1}^N \left\{ \int_{A^e} \int_{h_{k-1}}^{h_k} \delta \left({}^t \hat{\mathbf{e}}_k^L \right)^T \hat{\mathbf{C}}_k {}^t \hat{\mathbf{e}}_k^L dz {}^t dA^e + \int_{A^e} \int_{h_{k-1}}^{h_k} \delta \left({}^t \hat{\mathbf{e}}_k^{NL} \right)^T {}^t \hat{\mathbf{s}}_k dz {}^t dA^e \right\} \\ & = {}^{t+\Delta t}_t \mathfrak{R}^e - \sum_{k=1}^N \int_{A^e} \int_{h_{k-1}}^{h_k} \delta \left({}^t \hat{\mathbf{e}}_k^L \right)^T {}^t \hat{\mathbf{s}}_k dz {}^t dA^e \end{aligned} \quad (25)$$

Substituting equations (16) and (18), into equation (25), we can write:

$$\begin{aligned} & \sum_{k=1}^N \left\{ \int_{A^e} \int_{h_{k-1}}^{h_k} \delta \left\{ \begin{bmatrix} \bar{\mathbf{e}}_k^L \\ -\bar{\mathbf{E}} \end{bmatrix} \right\}^T \begin{bmatrix} \bar{\mathbf{Q}} & \bar{\mathbf{e}} \\ \bar{\mathbf{e}}^T & \bar{\mathbf{p}} \end{bmatrix}_k \left\{ \begin{bmatrix} \bar{\mathbf{e}}_k^L \\ -\bar{\mathbf{E}} \end{bmatrix} \right\} dz {}^t dA^e + \int_{A^e} \int_{h_{k-1}}^{h_k} \delta \left\{ \begin{bmatrix} \bar{\mathbf{e}}_k^{NL} \\ 0 \end{bmatrix} \right\}^T {}^t \hat{\mathbf{s}}_k dz {}^t dA^e \right\} \\ & = {}^{t+\Delta t}_t \mathfrak{R}^e - \sum_{k=1}^N \int_{A^e} \int_{h_{k-1}}^{h_k} \delta \left\{ \begin{bmatrix} \bar{\mathbf{e}}_k^L \\ -\bar{\mathbf{E}} \end{bmatrix} \right\}^T {}^t \hat{\mathbf{s}}_k dz {}^t dA^e \end{aligned} \quad (26)$$

By assuming that the loading is independent of the state of deformation, the term corresponding to the external virtual work is given by:

$$\begin{aligned} {}^{t+\Delta t}_t \mathfrak{R} = & \int_{0_V} {}^{t+\Delta t}_0 f \delta u d^0 V + \int_{0_S} {}^{t+\Delta t}_0 T \delta u d^0 S + \sum_i F_i \delta u_i + \\ & \int_{0_V} {}^{t+\Delta t}_0 q \delta \phi d^0 V + \int_{0_S} {}^{t+\Delta t}_0 Q \delta \phi d^0 S + \sum_i P_i \delta \phi_i \end{aligned} \quad (27)$$

where f is the body force, T the surface traction, F_i the concentrated force, q the body charge, Q the surface charge and P_i the point charge.

In the present work a three node triangular flat plate element is used to carry out geometrically non-linear analysis of general multilayered thin composite plate-shell type structures. As it is shown in Figure 1, the element has three nodes and six degrees of freedom per node, the displacements u_i v_i w_i and rotations θ_{xi} , θ_{yi} , θ_{zi} . It requires the introduction of fictitious stiffness coefficients $K_{\theta z}$, corresponding to rotations θ_z , which does not enter in the formulation in the local coordinate system (x, y, z) [11]. The element local displacements u , v , w , are expressed in terms of nodal variables through shape functions given in terms of area co-ordinates L_i [11]:

$$\mathbf{d} = \sum_{i=1}^3 \mathbf{N}_i \mathbf{d}_i = \mathbf{N} \mathbf{a}^e \quad (28)$$

Thus the membrane and bending strain vectors at any point, are expressed by the equations:

$$\bar{\mathbf{e}}_m = \sum_{i=1}^3 \mathbf{B}_i^m \mathbf{d}_i = \mathbf{B}^m \mathbf{a}_m^e \quad (29)$$

$$\bar{\mathbf{e}}_b = \sum \mathbf{B}_i^b \mathbf{d}_i = \mathbf{B}^b \mathbf{a}_b^e \quad (30)$$

where the sub-matrices $\mathbf{N}_i$, $\mathbf{B}_i^m$ and $\mathbf{B}_i^b$ are given by:

$$[\mathbf{N}_i] = \begin{bmatrix} L_i & 0 & 0 & 0 & 0 & 0 \\ 0 & L_i & 0 & 0 & 0 & 0 \\ 0 & 0 & {}^1N_i & {}^2N_i & {}^3N_i & 0 \\ 0 & 0 & -\frac{\partial {}^1N_i}{\partial y} & -\frac{\partial {}^2N_i}{\partial y} & -\frac{\partial {}^3N_i}{\partial y} & 0 \\ 0 & 0 & \frac{\partial {}^1N_i}{\partial x} & \frac{\partial {}^2N_i}{\partial x} & \frac{\partial {}^3N_i}{\partial x} & 0 \end{bmatrix} \quad (31)$$

$$[\mathbf{B}_i^m] = \begin{bmatrix} \frac{\partial L_i}{\partial x} & 0 & 0 & 0 & 0 & 0 \\ 0 & \frac{\partial L_i}{\partial y} & 0 & 0 & 0 & 0 \\ \frac{\partial L_i}{\partial y} & \frac{\partial L_i}{\partial x} & 0 & 0 & 0 & 0 \end{bmatrix}; [\mathbf{B}_i^b] = \begin{bmatrix} 0 & 0 & -\frac{\partial^2 {}^1N_i}{\partial x^2} & -\frac{\partial^2 {}^2N_i}{\partial x^2} & -\frac{\partial^2 {}^3N_i}{\partial x^2} & 0 \\ 0 & 0 & -\frac{\partial^2 {}^1N_i}{\partial y^2} & -\frac{\partial^2 {}^2N_i}{\partial y^2} & -\frac{\partial^2 {}^3N_i}{\partial y^2} & 0 \\ 0 & 0 & -2\frac{\partial^2 {}^1N_i}{\partial x \partial y} & -2\frac{\partial^2 {}^2N_i}{\partial x \partial y} & -2\frac{\partial^2 {}^3N_i}{\partial x \partial y} & 0 \end{bmatrix} \quad (32)$$

The electric field is given by

$$\mathbf{E} = -\mathbf{B}^\phi \phi \quad (33)$$

Substituting the last equations into equation (26), becomes:

$$\begin{aligned} & \sum_{K=1}^N \left\{ \int_{t_A^e}^{h_k} \delta \begin{Bmatrix} a \\ \phi \end{Bmatrix}^T \begin{bmatrix} \mathbf{B}^{mb} & 0 \\ 0 & \mathbf{B}^\phi \end{bmatrix}^T \begin{bmatrix} \bar{Q} & \bar{e} \\ \bar{e}^T & -\bar{p} \end{bmatrix}_k \begin{bmatrix} \mathbf{B}^{mb} & 0 \\ 0 & \mathbf{B}^\phi \end{bmatrix} \begin{Bmatrix} a \\ \phi \end{Bmatrix} dz \right\} {}^t dA^e + \\ & \left\{ \int_{t_A^e}^{h_k} \delta \begin{Bmatrix} a \\ 0 \end{Bmatrix}^T \begin{bmatrix} \mathbf{B}^{nl} & 0 \\ 0 & 0 \end{bmatrix}^T \begin{Bmatrix} \bar{\sigma} \\ 0 \end{Bmatrix}_k dz \right\} {}^t dA^e = \\ & {}^{t+\Delta t} \mathfrak{R}_t^e - \sum_{k=1}^N \int_{t_A^e}^{h_k} \delta \begin{Bmatrix} a \\ \phi \end{Bmatrix}^T \begin{bmatrix} \mathbf{B}^{mb} & 0 \\ 0 & \mathbf{B}^\phi \end{bmatrix}^T \begin{Bmatrix} \bar{\sigma} \\ \bar{D} \end{Bmatrix}_k dz {}^t dA^e \end{aligned} \quad (34)$$

To the first term of first member of equation (26) corresponds the linear stiffness matrix, which is defined by

$$\mathbf{K}_L^e = \begin{bmatrix} K_{uu}^L & K_{u\phi}^L \\ K_{\phi u}^L & K_{\phi\phi}^L \end{bmatrix} = \sum_{K=1}^N \int_{t_A^e} \int_{h_{k-1}}^{h_k} \begin{bmatrix} \mathbf{B}^{mb} & 0 \\ 0 & \mathbf{B}^\phi \end{bmatrix}^T \begin{bmatrix} \bar{\mathbf{Q}} & \bar{\mathbf{e}} \\ \bar{\mathbf{e}}^T & -\bar{\mathbf{p}} \end{bmatrix}_k \begin{bmatrix} \mathbf{B}^{mb} & 0 \\ 0 & \mathbf{B}^\phi \end{bmatrix} dz \, {}^t dA^e \quad (35)$$

where we have:

$$\begin{aligned} K_{uu}^L &= \sum_{K=1}^N \int_{t_A^e} \int_{h_{k-1}}^{h_k} \mathbf{B}^{mbT} \bar{\mathbf{Q}} \mathbf{B}^{mb} dz \, {}^t dA \quad ; \quad K_{u\phi}^L = \sum_{K=1}^N \int_{t_A^e} \int_{h_{k-1}}^{h_k} \mathbf{B}^{mbT} \bar{\mathbf{e}} \mathbf{B}^\phi dz \, {}^t dA \\ K_{\phi u}^L &= \sum_{K=1}^N \int_{t_A^e} \int_{h_{k-1}}^{h_k} \mathbf{B}^{\phi T} \bar{\mathbf{e}}^T \mathbf{B}^{mb} dz \, {}^t dA \quad K_{\phi\phi}^L = \sum_{K=1}^N \int_{t_A^e} \int_{h_{k-1}}^{h_k} \mathbf{B}^{\phi T} \bar{\mathbf{p}} \mathbf{B}^\phi dz \, {}^t dA \end{aligned} \quad (36)$$

The second term of the first member of equation (26), can be written in the form:

$$\sum_{i=1}^N \int_{t_A^e} \int_{h_{k-1}}^{h_k} \delta \left({}_t \bar{\mathbf{e}}_k^{NL} \right)^T {}_t \bar{\mathbf{s}}_k dz \, {}^t dA^e = \int_{t_A^e} \left(\hat{\boldsymbol{\sigma}}_{ij} \right)^T \delta \left[\frac{1}{2} \left(u_{s,i} u_{s,j} \right) \right] {}^t dA^e \quad (37)$$

where $i,j = x,y$ and $u_s = u, v, w$

Considering the displacements on the reference surface only, the last equation can be written

$$\begin{aligned} \int_{t_A^e} \hat{\boldsymbol{\sigma}}_{ij} \delta \left[\frac{1}{2} \left(u_{s,i} u_{s,j} \right) \right] {}^t dA^e &= \int_{t_A^e} \left\{ N_x [u_{0,x} \delta u_{0,x} + v_{0,x} \delta v_{0,x} + w_{0,x} \delta w_{0,x}] + \right. \\ &\quad \left. 2N_{xy} [u_{0,x} \delta u_{0,y} + v_{0,x} \delta v_{0,y} + w_{0,x} \delta w_{0,y}] + N_y [u_{0,y} \delta u_{0,y} + v_{0,y} \delta v_{0,y} + w_{0,y} \delta w_{0,y}] \right\} {}^t dA^e \end{aligned} \quad (38)$$

Thus the second term of the first member of equation (26), can be written in the form [12]:

$$\sum_{i=1}^N \int_{t_A^e} \int_{h_{k-1}}^{h_k} \delta \left({}_t \bar{\mathbf{e}}_k^{NL} \right)^T {}_t \bar{\mathbf{s}}_k dz \, {}^t dA^e = \int_{t_A^e} \delta \mathbf{a}^{eT} \left(\mathbf{G}^T \mathbf{t} \mathbf{G} \right) \mathbf{a}^e {}^t dA^e \quad (39)$$

and the geometric stiffness matrix for the element is then given by:

$$\mathbf{K}_\sigma^e = \begin{bmatrix} K_{uu}^\sigma & K_{u\phi}^\sigma \\ K_{\phi u}^\sigma & K_{\phi\phi}^\sigma \end{bmatrix} = \begin{bmatrix} K_{uu}^\sigma & 0 \\ 0 & 0 \end{bmatrix} \quad (40)$$

with

$$K_{uu}^\sigma = \int_{t_A^e} \mathbf{G}^T \mathbf{t} \mathbf{G} {}^t dA \quad (41)$$

where the non-linear strain-displacement matrix G , and the matrix of actual membrane forces t , are given by:

$$[G_i] = \begin{bmatrix} \frac{\partial L_i}{\partial x} & 0 & 0 & 0 & 0 & 0 \\ \frac{\partial L_i}{\partial y} & 0 & 0 & 0 & 0 & 0 \\ 0 & \frac{\partial L_i}{\partial x} & 0 & 0 & 0 & 0 \\ 0 & \frac{\partial L_i}{\partial y} & 0 & 0 & 0 & 0 \\ 0 & 0 & \frac{\partial_1 N_i}{\partial x} & \frac{\partial_2 N_i}{\partial x} & \frac{\partial_3 N_i}{\partial x} & 0 \\ 0 & 0 & \frac{\partial_1 N_i}{\partial y} & \frac{\partial_2 N_i}{\partial y} & \frac{\partial_3 N_i}{\partial y} & 0 \end{bmatrix}; t = \begin{bmatrix} N_{xx} & N_{xy} & 0 & 0 & 0 & 0 \\ N_{xy} & N_{yy} & 0 & 0 & 0 & 0 \\ 0 & 0 & N_{xx} & N_{xy} & 0 & 0 \\ 0 & 0 & N_{xy} & N_{yy} & 0 & 0 \\ 0 & 0 & 0 & 0 & N_{xx} & N_{xy} \\ 0 & 0 & 0 & 0 & N_{xy} & N_{yy} \end{bmatrix} \quad (42)$$

The first term of second member of equation (26), taken into accounting equation (28), and assuming the electric charge is zero, can be written as:

$${}^{t+\Delta t} \mathfrak{R} = \int_{A^e} \delta \mathbf{a}^e{}^T \mathbf{N}^e{}^T \mathbf{p}^e{}^0 dA^e + \int_{S^e} \delta \mathbf{a}^e{}^T \mathbf{N}^e{}^T \mathbf{t}^e{}^0 dS^e + \delta \mathbf{a}^e{}^T \mathbf{F}_c^e \quad (43)$$

where $\mathbf{p}^e$, $\mathbf{t}^e$, $\mathbf{F}^e$ are the surface distributed, side distributed and concentrated force vectors.

The external force vector is then defined

$$\mathbf{F}_{ext}^e = \int_{A^e} \mathbf{N}^e{}^T \mathbf{p}^e{}^0 dA^e + \int_{S^e} \mathbf{N}^e{}^T \mathbf{t}^e{}^0 dS^e + \mathbf{F}_c^e \quad (44)$$

To the second term of second member of equation (26), corresponds the internal force, which is defined by:

$$\mathbf{F}_{int}^e = \left\{ \begin{matrix} F_{int}^1 \\ F_{int}^2 \end{matrix} \right\} = \int_{A^e} \begin{bmatrix} \mathbf{B}^{mb} & 0 \\ 0 & \mathbf{B}^\phi \end{bmatrix}^T \begin{Bmatrix} \tilde{\mathbf{s}} \\ \tilde{\mathbf{D}} \end{Bmatrix} {}^t \mathbf{t} dA^e = \int_{A^e} \begin{Bmatrix} \mathbf{B}^{mb}{}^T \\ \mathbf{B}^{\phi T} \end{Bmatrix} \begin{Bmatrix} \tilde{\mathbf{s}} \\ \tilde{\mathbf{D}} \end{Bmatrix} {}^t \mathbf{t} dA^e \quad (45)$$

Equation (26) is valid for any virtual displacement field, $\delta \mathbf{a}^e$ and $\delta \phi^e$. Considering the relations (35), (41), (44), (45), and introducing an iteration cycle, we have:

$${}^{t+\Delta t} \left(\mathbf{K}_L^e + \mathbf{K}_\sigma^e \right)^{(k-1)} \left(\Delta \hat{\mathbf{a}}^e \right)^{(k)} = {}^{t+\Delta t} \mathbf{F}_{ext}^e - {}^{t+\Delta t} \left(\mathbf{F}_{int}^e \right)^{(k-1)} \quad (46)$$

Numerical integration is used, with 3 Gauss points for matrices $\mathbf{K}_L^e$ and $\mathbf{K}_\sigma^e$ and force vectors $\mathbf{F}_{ext}^e$ and $\mathbf{F}_{int}^e$. The element geometry, as well as stiffness matrices and external load vector are initially computed in the local coordinate system attached to the element. To solve general structures,

local - global transformations are needed [11]. After these transformations, the system incremental equations in referential X,Y,Z are:

$${}_{t+\Delta t}^{t+\Delta t}(\mathbf{K}_L + \mathbf{K}_\sigma)^{(k-1)} (\Delta \hat{\mathbf{q}})^{(k)} = {}_{t+\Delta t}^{t+\Delta t} \mathbf{F}_{\text{ext}} - {}_{t+\Delta t}^{t+\Delta t} (\mathbf{F}_{\text{int}})^{(k-1)} \quad (47)$$

where $\Delta \hat{\mathbf{q}} = \{\Delta \mathbf{q} \ \Delta \phi^{(s)}\}^T$ is the vector of incremental generalized displacements and electrical potentials, in the global coordinate system.

Assuming that piezoelectric sensors as well as actuators are bonded or embedded in the structure, the previous equation can be written in the following developed form:

$${}_{t+\Delta t}^{t+\Delta t} \left(\begin{bmatrix} \mathbf{K}_{uu}^L & \mathbf{K}_{u\phi}^{L(s)} \\ \mathbf{K}_{\phi u}^{L(s)} & \mathbf{K}_{\phi\phi}^{L(s)} \end{bmatrix} + \begin{bmatrix} \mathbf{K}_{uu}^s & 0 \\ 0 & 0 \end{bmatrix} \right)^{(k-1)} \begin{Bmatrix} \Delta \mathbf{q} \\ \Delta \phi^{(s)} \end{Bmatrix}^{(k)} = \begin{Bmatrix} \mathbf{F}_{\text{ext}}^{\text{mec}} - {}_{t+\Delta t}^{t+\Delta t} \left(\mathbf{K}_{u\phi}^{L(A)} \Delta \phi^{(A)} \right) \\ - {}_{t+\Delta t}^{t+\Delta t} \left(\mathbf{K}_{\phi\phi}^{L(A)} \Delta \phi^{(A)} \right) \end{Bmatrix} - {}_{t+\Delta t}^{t+\Delta t} \begin{Bmatrix} \mathbf{F}_{\text{int}}^1 \\ \mathbf{F}_{\text{int}}^2 \end{Bmatrix} \quad (48)$$

where A and S means actuator and sensor, respectively.

When we have actuators or sensors only, the system of equations (48) take the following forms, respectively:

$${}_{t+\Delta t}^{t+\Delta t} \left(\mathbf{K}_{uu}^L + \mathbf{K}_{uu}^\sigma \right)^{(k-1)} \{\Delta \mathbf{q}\}^{(k)} = {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{F}_{\text{ext}}^{\text{mec}} \right\} - {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{K}_{u\phi}^{L(A)} \Delta \phi^{(A)} \right\} - {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{F}_{\text{int}}^1 \right\} \quad (49)$$

$${}_{t+\Delta t}^{t+\Delta t} \left(\begin{bmatrix} \mathbf{K}_{uu}^L & \mathbf{K}_{u\phi}^{L(s)} \\ \mathbf{K}_{\phi u}^{L(s)} & \mathbf{K}_{\phi\phi}^{L(s)} \end{bmatrix} + \begin{bmatrix} \mathbf{K}_{uu}^\sigma & 0 \\ 0 & 0 \end{bmatrix} \right)^{(k-1)} \begin{Bmatrix} \Delta \mathbf{q} \\ \Delta \phi^{(s)} \end{Bmatrix}^{(k)} = {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{F}_{\text{ext}} \right\} - {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{F}_{\text{int}} \right\} \quad (50)$$

where $\mathbf{F}^{\text{act}} = {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{K}_{u\phi}^{L(A)} \Delta \phi^{(A)} \right\}$ is the force vector due to the voltage applied to the actuators.

The system of equations (50) can be decomposed, taking the form

$${}_{t+\Delta t}^{t+\Delta t} \left[\mathbf{K}_{uu}^L + \mathbf{K}_{uu}^\sigma \right]^{(k-1)} \{\Delta \mathbf{q}\}^{(k)} = {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{F}_{\text{ext}}^{\text{mec}} \right\} - {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{F}_{\text{int}}^1 \right\} \quad (51)$$

$$\{\Delta \phi\}^{(k)} = - \left[{}_{t+\Delta t}^{t+\Delta t} \left[\mathbf{K}_{\phi\phi}^{L(s)} \right]^{(k-1)} \right]^{-1} \left\{ {}_{t+\Delta t}^{t+\Delta t} \left[\mathbf{K}_{\phi u}^{L(s)} \right]^{(k-1)} \{\Delta \mathbf{q}\}^{(k)} - {}_{t+\Delta t}^{t+\Delta t} \left\{ \mathbf{F}_{\text{int}}^2 \right\} \right\} \quad (52)$$

Once the boundary conditions are introduced in the usual way, the system equations (49) or the system equations (51) and (52) are solved incrementally and iteratively using the Newton-Raphson technique [13].

5. Numerical Applications

5.1 Linear analysis of a piezoelectric bimorph beam.

A linear analysis of a cantilevered piezoelectric bimorph beam, with two PVDF layers bonded together and polarized in opposite directions, with the dimensions indicated in Figure 2, is considered. The mechanical and piezoelectric properties of the PVDF are:

$$E_1 = E_2 = 2 \text{ GPa}, G_{12} = 1 \text{ GPa}, \nu_{12} = 0, e_{31} = e_{32} = 0.046 \text{ C/m}^2, p_{33} = 1.062 \times 10^{-10} \text{ F/m}.$$

The top and bottom surfaces of the beam are subjected to an electric potential of 1V. The deflections in different locations of the beam, using a (5x2) element mesh, are presented in Table 1, which are compared with alternative solutions. The sensing voltage distribution of the bimorph beam for a prescribed tip deflection of 10 mm, is also analysed. The present predictions, and solutions obtained by other authors are shown in Table 2. The results are in good agreement with the alternative solutions.

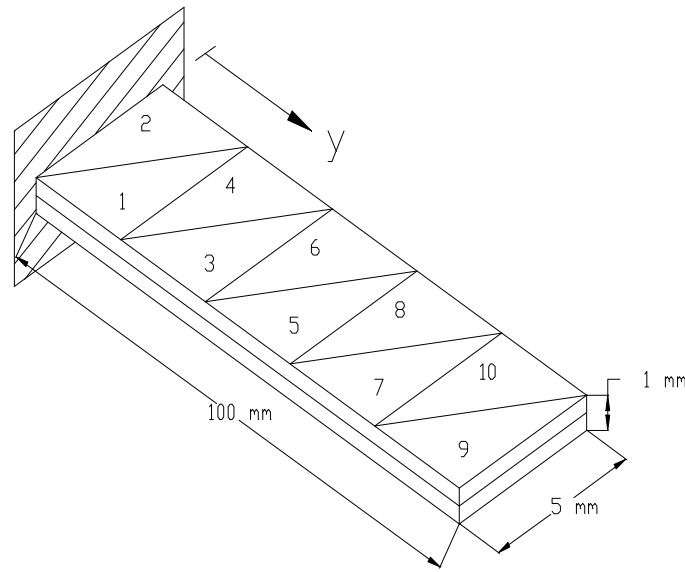


Figure 2. Piezoelectric bimorph beam.

Location y (mm)	Deflections $\times 10^{-7}$ m				
	20	40	60	80	100
Analytical solution					
Suleman and Venkayya [12]	0.138	0.552	1.24	2.21	3.45
Q9-FSDT5P					
Franco <i>et al.</i> [4]	0.138	0.552	1.24	2.11	3.45
FSDT4P					
Suleman and Venkayya [12]	0.14	0.55	1.24	2.21	3.45
CPT					
Present Solution	0.137	0.550	1.240	2.210	3.45
Experimental					
Suleman and Venkayya [12]	-	-	-	-	3.45

Table 1. Deflections produced by a unit voltage.

Elements	Sensed voltage (V)				
	1 and 2	3 and 4	5 and 6	7 and 8	9 and 10
Q9-FSDT5P					
Franco <i>et al.</i> [4]	290	226	161	97	32
FSDT4P					
Suleman e Venkayya [12]	290	-	-	-	-
Present Solution (CPT)	295	229	163	98	32

Table 2. Sensed voltage distribution for a tip deflection of 10 mm.

5.2 Non-linear analysis of a piezoelectric bimorph beam.

The sensing voltage on the elements 1 and 2 of the same cantilevered piezoelectric bimorph beam, is now analysed considering non-linear deformation. In Table 3 are shown the results for different load levels, where the load level $\mu=1.0$ corresponds to the tip deflection of 10.0 mm in linear analysis. As expected from Table 3 a slightly decrease in the tip deflection is observed for the non-linear model, then resulting a lower voltage.

Load level μ	Linear analysis		Non-linear analysis	
	Sensed voltage (V)	Tip deflection (mm)	Sensed voltage (V)	Tip deflection (mm)
0.2	59.00	2.00	59.00	2.00
0.4	118.00	4.00	117.76	3.99
0.6	177.00	6.00	176.42	5.98
0.8	236.00	8.00	234.91	7.94
1.0	295.00	10.00	293.08	9.89

Table 3. Sensed voltage on elements 1 and 2 for different load levels

5.3 Adaptive composite plate with surface bonded actuators

A simply-supported square (axa) laminated plate, with lamination sequence $[p/45^\circ/-45^\circ/45^\circ/p]$, where p represents the piezoelectric layers made of PXE-52, bonded on upper and lower surfaces, and the other layers are made of S-glass/epoxy. The plate is subjected to a uniform distributed load of 10 kN/m².

The material properties of S-glass/epoxy are : $E_1 = 55$ GPa, $E_2 = 16$ GPa, $G_{12} = 7.6$ GPa, $\nu_{12} = 0.28$. The material and piezoelectric properties of PXE-52 are, $E_1 = E_2 = 62.5$ GPa,

$G_{12} = 24 \text{ GPa}$, $\nu_{12} = 0.3$, $d_{31} = d_{32} = -280 \times 10^{-12} \text{ m/V}$, $d_{33} = 700 \times 10^{-12} \text{ m/V}$, $p_{33} = 3.45 \times 10^{-8} \text{ F/m}$.

The side dimension is $a = 0.1 \text{ m}$ and the thickness of the layers S-glass/epoxy and PXE-52 are 0.0004 m and 0.0002 m respectively.

The central deflection of the plate in linear analysis, for the uniform distributed load of $p_0 = 10 \text{ kN/m}^2$ has the value of $w = 0.217 \text{ mm}$, using a (8×8) element mesh. Next it are applied voltages V_0 of 151.35 V and -151.35 V on the lower and upper piezoelectric layers, in order to reduce the central deflection, produced by the mechanical load. The central deflection prediction of the present model shown in Table 4, are in a very good agreement with the alternative linear solution obtained by Franco *et al* [4], using a first order shear deformation piezolaminated 9 node plate element, with Lagrangian C^0 shape functions to represent the generalized displacement field defined in the reference surface, and a constant potential degree of freedom for each piezoelectric layer within each element (Q9-FSDT5P model).

Applied loads				
10 kN/m^2		10 kN/m^2	10 kN/m^2	
		+	+	
		$151.35 \text{ V} / -151.35 \text{ V}$	$151.94 \text{ V} / -151.94 \text{ V}$	
a)	b)	a)	b)	
Central deflection				
$w_c \text{ (mm)}$	0.217	0.218	0.01	0.01
a) Present solution (CPT) ; b) Franco <i>et al.</i> [4] (FSDT)				

Table 4. Central deflection for different load cases in linear analysis.

The same plate is also analysed taking into account non-linear deformations, for different load levels, defined by $L = \mu (p_0 + V_0)$. Due to the lack of alternative comparing results, in Table 5 a convergence study is shown for non-linear central deflection at load level $\mu = 3$. It can be observed that for the meshes 8×8 and 10×10 the response is almost the same for the three cases of loading considered.

Mesh	Total number of elements	Mechanical load	Electric load	Mechanical + Electric loads
2x2	16	0.501×10^{-3}	-0.550×10^{-3}	-0.531×10^{-5}
4x4	32	0.608×10^{-3}	-0.578×10^{-3}	0.322×10^{-5}
6x6	72	0.618×10^{-3}	-0.589×10^{-3}	0.332×10^{-5}
8x8	128	0.621×10^{-3}	-0.592×10^{-3}	0.336×10^{-5}
10x10	200	0.622×10^{-3}	-0.593×10^{-3}	0.337×10^{-5}

Table 5. Convergence study for non-linear central deflection $w_c \text{ (m)}$, at load level $\mu = 3.0$

5.4 Adaptive laminated cylindrical panel with surface bonded actuators.

A laminated cylindrical panel, Figure 3, with lamination sequence $[p/90^\circ/0^\circ/90^\circ/p]$, where p represents the piezoelectric layers made of PXE-52, bonded on upper and lower surfaces, and the other layers are made of S-glass/epoxy, is subjected to a concentrated central load. The panel is hinged in the straight edges, and free in the curved edges. The properties of two materials and the layers thickness are those indicated in previous application, and the geometry of the panel is: $R=2540$ mm, $L=508$ mm, $\theta = 0.1$ rad. In Figure 4 are shown the load-displacement curves for two load cases, obtained with a (8x8) element mesh. The mechanical load is defined by $F_{\text{ext}} = \mu F_{\text{ext}}^0$ with $F_{\text{ext}}^0 = 30$ N, and the electric load by $V = \mu V_0$ with $V_0=250$ V. Other researchers can use the present predictions to validate alternative non-linear piezolaminated shell models.

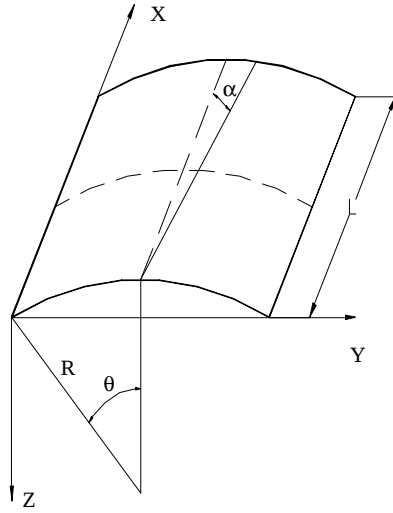


Figure 4. Cylindrical panel.

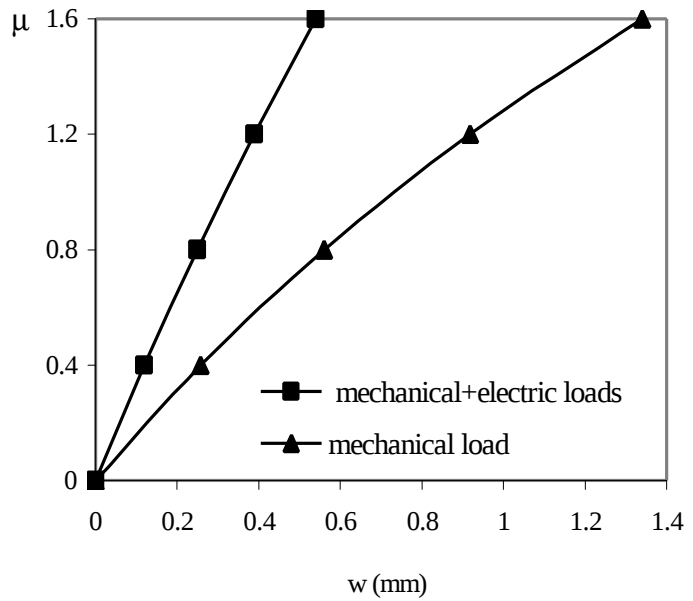


Figure 5. Load-displacement curves.

6. Conclusions

A finite element model based on the Kirchhoff classical theory has been developed for the geometrically non-linear analysis of piezolaminated plates and shells, using update Lagrangian formulation. The model has been applied to linear and non-linear analyses of simple illustrative problems. The results obtained in linear analysis are compared with alternative models and an excellent agreement is achieved. The results also show that the transverse displacements are significantly influenced by the geometrically non-linear analysis. Due to the lack of available examples in the open literature, others can use the shown illustrative applications as a benchmark for comparing purposes.

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